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PATENT  
Docket No. 150.0081 0102

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant(s): Brian A. Vaartstra ) Group Art Unit: 2823  
Serial No.: 09/865,612 ) Examiner: unknown  
Confirmation No.: 4697 )  
Filed: May 25, 2001 )  
For: METHODS, COMPLEXES, AND SYSTEMS FOR FORMING METAL-  
CONTAINING FILMS ON SEMICONDUCTOR STRUCTURES

## **INFORMATION DISCLOSURE STATEMENT**

Assistant Commissioner for Patents  
Washington D.C. 20231

Sir:

In compliance with the duty imposed by 37 C.F.R. § 1.56, and in accordance with C.F.R. §§ 1.97 *et. seq.*, the materials enclosed herewith are brought to the attention of the Examiner as possibly being of interest in connection with the above-identified patent application. Consideration of each of the documents listed on the attached 1449 forms is respectfully requested. Pursuant to the provisions of M.P.E.P. §609, Applicant further requests that a copy of the 1449 forms, marked as being considered and initialed by the Examiner, be returned with the next Official Communication.

This application is a divisional of U.S. Patent Application Serial No. 09/146,003 (issued as U.S. Patent No. 6,281,124 B1). In accordance with 37 C.F.R. §1.98(d), copies of documents previously cited by or submitted to the U.S. Patent Office in connection with Applicant's prior application Serial No. 09/146,003, are not included herewith.

Applicant(s): *Brian A. Vaartstra*  
Serial No.: *09/865,612*  
Confirmation No.: *4697*  
Filed: *May 25, 2001*  
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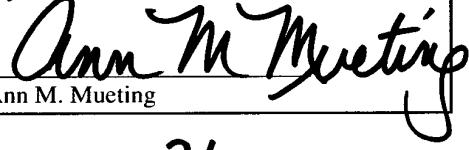
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It is believed that no fee is due, as this Information Disclosure Statement is filed prior to the receipt of any Action on the merits. However, in the event a fee is due, please charge any fee or credit any overpayment to Account No. 13-4895.

The Examiner is invited to contact Applicant's Representatives at the below-listed telephone number, if they can be of any assistance during prosecution of the present application.

**CERTIFICATE UNDER 37 C.F.R. 1.8:**

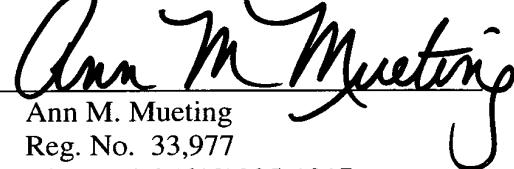
The undersigned hereby certifies that this paper is being deposited in the United States Postal Service, as first class mail, in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231, on this 21 day of November, 2001.

  
Ann M. Muetting

November 21, 2001  
Date

AMM/amr/lmg

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